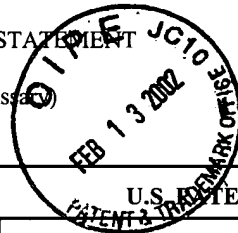


Form PTO-1449

U.S. Department of Commerce
Patent and Trademark OfficeAtty. Docket No.
P21519Serial No.
09/926,513INFORMATION DISCLOSURE STATEMENT
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Applicant
Andreas KRELL et al.Filing Date
November 13, 2001Group
Not Known

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/	4 2 5 9 3 1 1	03/31/81	SHAH			
/	4 5 6 2 0 5 9	12/31/85	ASAOKA et al.			
/	5 1 3 9 5 4 0	08/18/92	NAJJAR et al.			
/	5 3 9 5 4 0 7	03/07/95	COTTRINGER et al.			
/	6 0 3 0 5 9 9	02/29/00	NOWECK et al.			
/	6 0 4 8 5 7 7	04/11/00	GARG			
/	4 9 5 4 4 6 2	09/04/90	WOOD et al.			
/	5 1 8 5 2 9 9	02/09/93	WOOD et al.			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
/	4 1 1 6 5 2 3	11/28/91	GERMANY			
/	4 4 0 7 2 9 6	09/07/95	GERMANY			
/	1 9 5 1 5 8 2 0	10/31/98	GERMANY			
/	1 9 6 3 8 4 4 2	03/26/98	GERMANY			
/	0 2 9 4 2 0 8	12/07/88	E.P.O.			
/	0 5 5 4 9 0 8	08/11/93	E.P.O.			
/	0 6 7 8 4 8 9	10/25/95	E.P.O.			
/	9 5 / 1 2 5 4 7	05/11/95	W.I.P.O.			

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/	1	Ma, Burgard and Naß annual report of the Institute for New Materials, Saarbrücken, 1994, pp. 65-67. *
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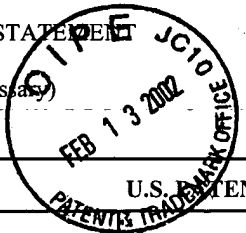
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				Filing Date November 13, 2001	Group Not Known

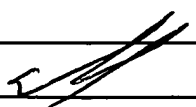


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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS							
DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO		

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